FIG. 1A

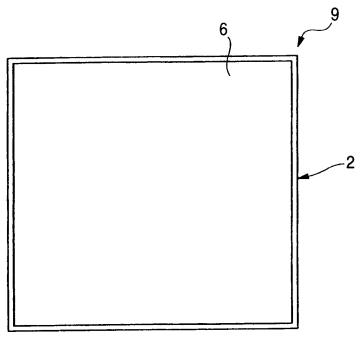
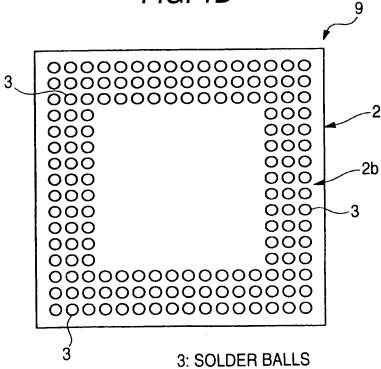


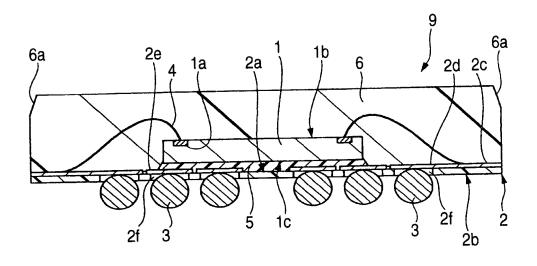
FIG. 1B



6: SEALED PORTION

9: CSP (SEMICONDUCTOR DEVICE)

FIG. 2



1a: PADS (SURFACE ELECTRODES) 2c: CONNECTION TERMINALS (ELECTRODES)

FIG. 3A

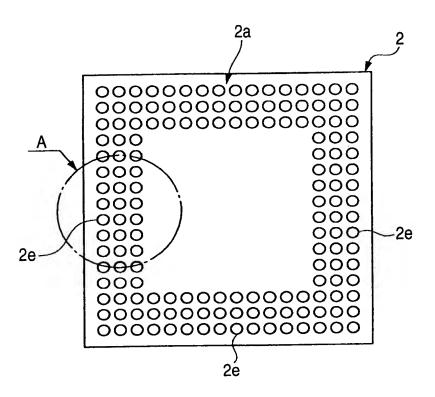


FIG. 3B

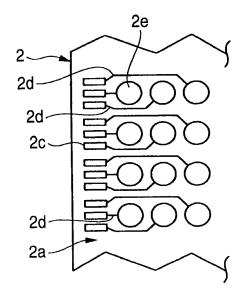
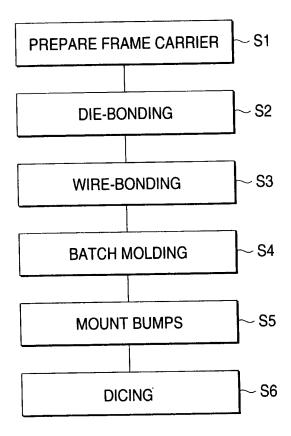
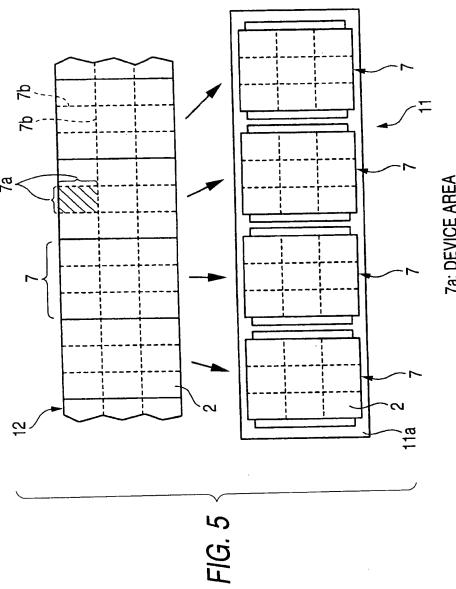
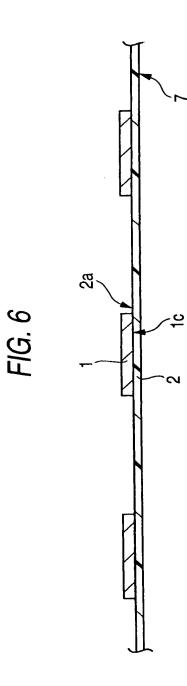


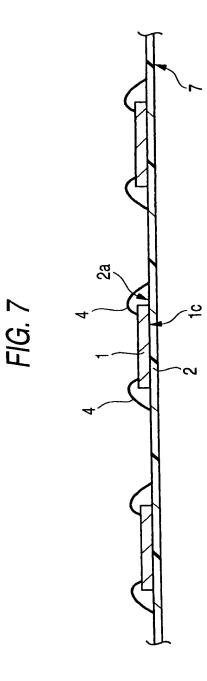
FIG. 4





7a: DEVICE AREA 7b: DICING LINES 11: FRAME CARRIER 11a: FRAME MEMBER







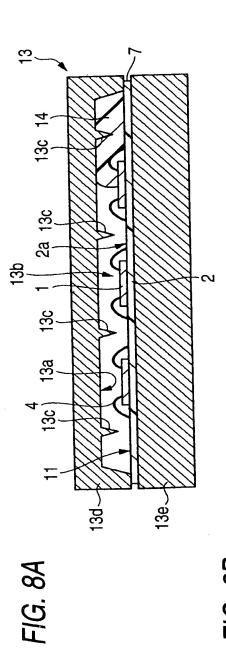


FIG. 8B

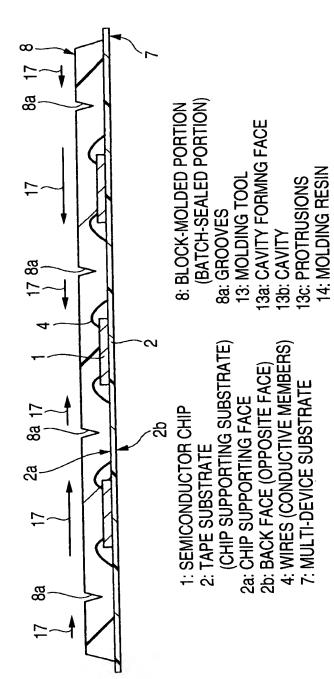
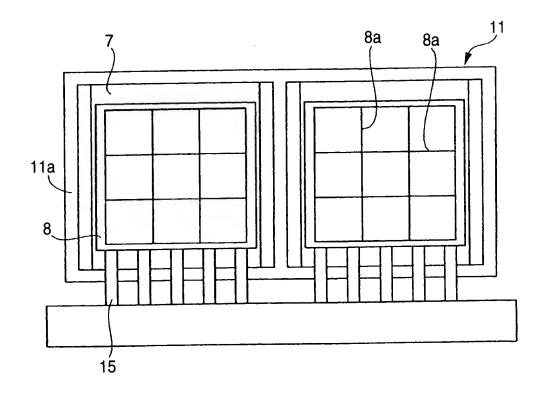


FIG. 9



g Sa gg.

FIG. 11A

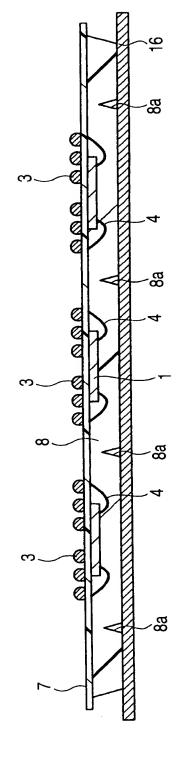
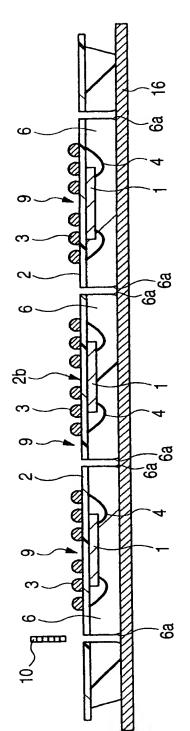


FIG. 11B



10: BLADE

FIG. 12

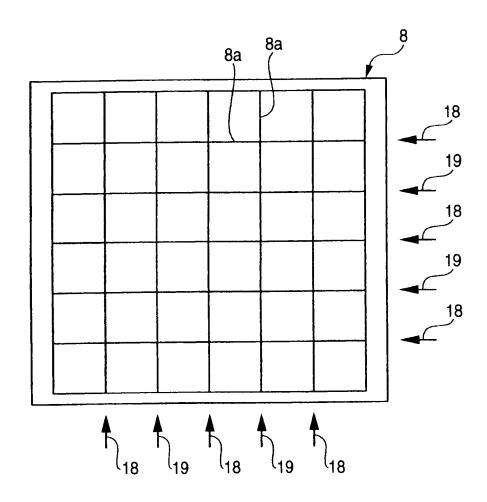


FIG. 13

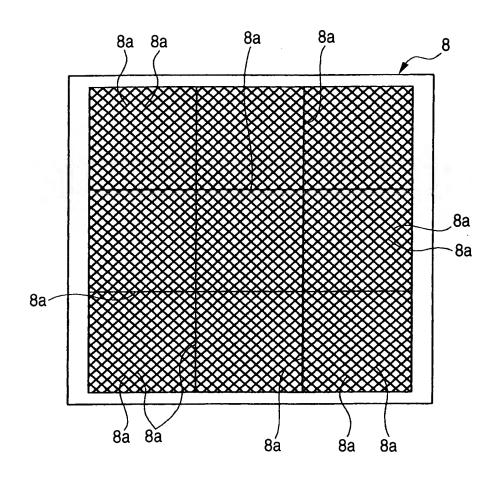


FIG. 14

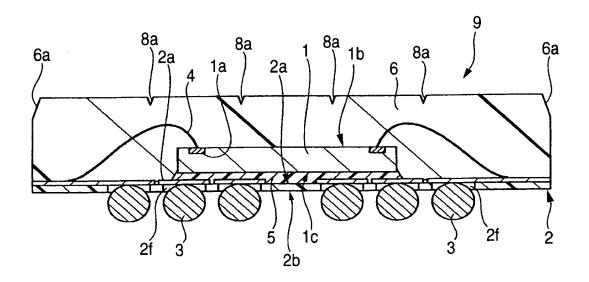
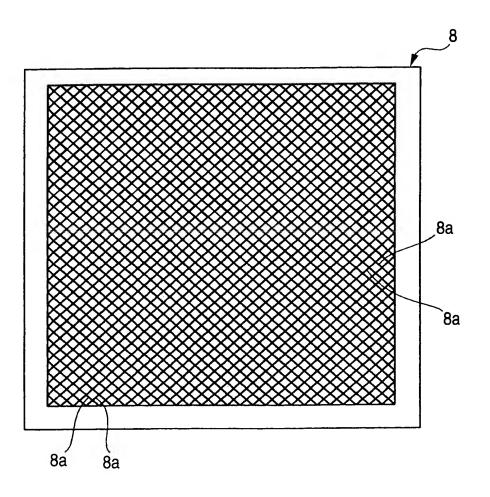


FIG. 15





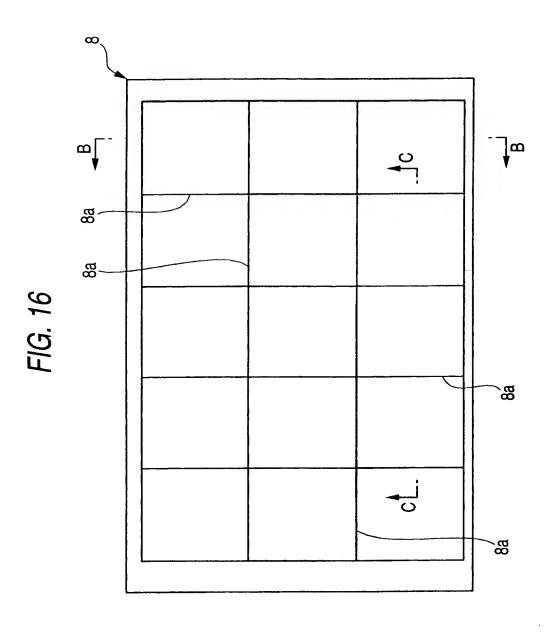


FIG. 17A

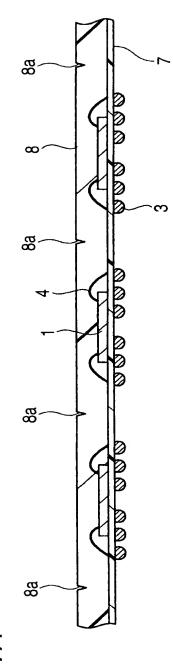


FIG. 17B

